

Continuous measurement of dust for very low and high concentrations





DUSTHUNTER C200

With two measuring principles prepared for the future

AREAS OF APPLICATION

- · Emission monitoring, for example in:
 - Power stations and heating plants
 - Waste incineration plants and waste disposal
 - Metal processing (steel and aluminum plants, smelting works, foundries)
 - Cement plants

- · Monitoring of filter systems
- Measurement of dust concentration in exhaust gas and exhaust air ducts before and after dust filters

TRANSMISSOMETRY

- For measurement in medium to high dust concentrations
- Automatic zero and reference point measurement
- Soiling measurement and correction on both sides
- Automatic self-alignment of optical axis
- With suitability test

SCATTERED LIGHT MEASUREMENT

- For measurement in very low and medium dust concentrations
- Automatic zero and reference point measurement
- Contamination measurement and correction
- Automatic self-alignment of optical axis
- · With suitability test

DUSTHUNTER C200

- For measurement in very low and high dust concentrations
- · Ensures future options
 - For stricter limit values
 - For changing dust concentrations
- · Redundant dust measurement
- · With suitability test

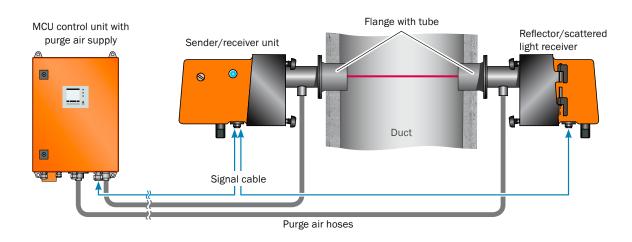
PERFORMANCE FEATURES

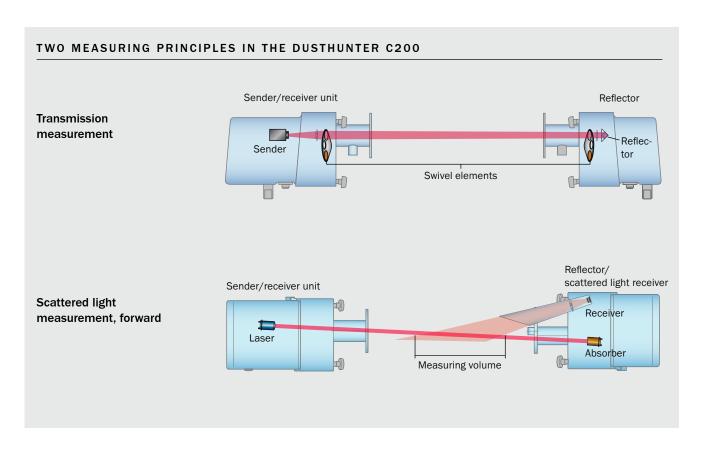
- · Combination of both measuring principles
- Reliable application through redundant measuring technology
- · Self-monitoring function
- Scattered light measuring principle for very low dust concentrations (< 5 mg/m³)
- Transmission measuring principle for high dust concentrations (< 10,000 mg/m³)
- · Contamination measurement and correction on both sides
- · Long maintenance intervals





SYSTEM COMPONENTS





Technical Data	DUSTHUNTER C200 – transmission and scattered light measuring device	
Device models	C200	
Measuring Parameters		
Measuring values	Transmission, opacity, extinction, dust concentration	
Available measuring ranges	Min.	Max.
Transmission	100 90 %	100 0 %
Opacity	0 10 %	0 100 %
Extinction	0 0.045	0 2.0
Dust concentration ¹⁾	Min. 0 5 mg/m³, max. 0 200 mg/m³, scattered light measurement Min. 0 200 mg/m³, max. 0 10.000 mg/m³, transmission measurement	
Distance (flange - flange)	0.5 8 m	
Measurement uncertainty	< ±2%	
Measuring Conditions		
Sample gas temperature ²⁾	-25 +300 °C	
Sample gas pressure	-50 +2 hPa -50 +30 hPa with external purge air unit option	
Ambient Conditions		
Ambient temperature	-40 +60 °C -40 +45 °C for MCU control unit with integrated purge air supply	
Approvals		
Conformities	 EN 15267-3, EN 14181 and DIN ISO 14956 TÜV-tested for equipment subject to authorization (2001/80/EC, 2000/76/EC) and plants of 27th FICA GOST, MCERTS in preparation U.S. EPA in preparation 	
Protection class	IP 66 for sender/receiver unit, reflector, MCU IP 54 for external purge air unit	
Electrical safety	CE	
Control Unit Inputs and Outputs	6	
Analog outputs ³⁾	3 outputs: 0/2/4 22 mA, max. load 750 Ω	
Analog inputs ³⁾	2 inputs: 0 5/10 V or 0 20 mA	
Digital outputs ³⁾	5 outputs: 30 V DC/2 A, 120 V AC/1 A; potential-free Status signals: operation/malfunction, maintenance, function check, service requirement, limit value	
Digital inputs ³⁾	4 inputs to connect potential-free contacts	
Interfaces	USB RS232 (service)	RS485 by optional interface module Ethernet by optional interface module
Bus protocol	TCP/IP via Ethernet (optional interface module) PROFIBUS-DP via RS485 (optional interface module)	
General		
System components	Sender/receiver unit Reflector/scattered light receiver MCU-P control unit with integrated purge air MCU-N control unit with ext. purge air (option)	 Connection cable Purge air hose Flanges with tube Hood for weather protection (option)
Operation	Via SOPAS ET software and/or display	
Check function	Zero and reference point test Soiling correction Automatic self-alignment	

 $^{^{\}mbox{\tiny 1)}}$ Depending on particle size and active measuring path



²⁾ Above dew point

³⁾ Extendable with additional I/O modules